

DFW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Karola Richter et al.

Serial No: 10/553,728

Art Unit: 1765

Filing Date: October 14, 2005

Title: SILICON SUBSTRATE COMPRISING POSITIVE  
ETCHING PROFILES WITH A DEFINED SLOPE ANGLE AND  
PRODUCTION METHOD

Examiner: Patricia Ann George



November 29, 2007

Attorney's Docket No.: HMP201T1

**TRANSMITTAL LETTER**

Hon. Commissioner for Patents and Trademarks

P.O. BOX 1450

Alexandria, Virginia 22313-1450

SIR:

Transmitted herewith for filing is:

<X> SUPPLEMENTAL AMENDMENT dated November 29, 2007 (11 pages)

<X> The Commissioner is hereby authorized to charge any fees under 37 CFR. 1.16, 1.17 and 1.18 or any additional fees which may be required during the entire pendency of the application, or credit any overpayment, to Acct. No.11-0224. A duplicate copy of this sheet is enclosed. If and only if(r) account funds should be insufficient, immediately contact our associate, Lisa Zumwalt, at (703)415-0579, who will pay immediately to avoid deprivation of rights.

< > Please charge my Deposit Account No.11-0224 in the amount of \$ \_\_\_\_\_. A duplicate copy of this sheet is enclosed.

A signature or signatures required for the above recited document(s) is (are) provided herebelow. Such signature(s) also provide(s) ratification for any required signature appearing to be defective in the above recited document(s).



Horst M. Kasper, 13 Forest Drive, Warren, N.J. 07059

Reg. No. 28,559 Tel.(908) 526-1717

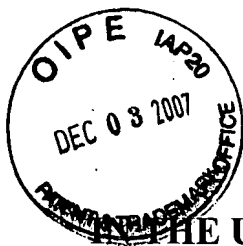
***CERTIFICATE OF MAILING under 37 CFR 1.8:***

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: *Hon. Commissioner for Patents, P.O. 1450, Alexandria, VA 22313,*

Signature: 

Date: NOV 29 2007

%HMP201-am



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Karola Richter et al.

Serial No: 10/553,728

Art Unit: 1765

Filing Date: October 14, 2005

Title: SILICON SUBSTRATE COMPRISING POSITIVE  
ETCHING PROFILES WITH A DEFINED SLOPE ANGLE AND  
PRODUCTION METHOD

Examiner: Patricia Ann George

November 29, 2007

Attorney's Docket No.: HMP201A3

**SUPPLEMENTAL AMENDMENT**

Hon. Commissioner of Patents and Trademarks

P.O. Box 1450, Alexandria, VA 22313

SIR:

This is in further response to the Office Action mailed on September 24, 2007, and setting a shortened statutory period for response of thirty days to expire on October 24, 2007. Applicants petition that, if required, the time for response be extended and the corresponding fee be charged. The Commissioner is hereby authorized to charge any additional fees which may be required to Acct. No. 11-0224. Applicants further respectfully request that this response be accepted as a bona fide effort to meet any potential response requirements outstanding and due in the above captioned matter.

Please amend the application as follows: